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PATENT APPLICATION
Docket No.: 8750-038
Client Ref. No.: SPX200212-0009US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Sung-Jin KIM, et al.

Serial No.:	10/685,655	Examiner:	Vu, Hung K.
Filed:	October 14, 2003	Group Art Unit:	2811
Confirmation No.:	5662		

For: PHOTO MASK SET FOR FORMING MULTI-LAYERED
INTERCONNECTION LINES AND SEMICONDUCTOR DEVICE
FABRICATED USING THE SAME

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

This Information Disclosure Statement is submitted:

☒   under 37 CFR 1.97 (b); or
(Within three months of filing national application; or date of entry of
International application; or before mailing date of first office action on the
merits; or before the mailing of a first Office Action after the filing of a request
for continued examination under §1.114; whichever occurs last)

☐   under 37 CFR 1.97 (c) together with either a:
     ☐   Statement under 37 CFR 1.97 (e), or
     ☐   a $180 fee under 37 CFR 1.17 (p); or
(After mailing of first Office Action, but prior to Notice of Allowance or Final
Office Action)

☐   under 37 CFR 1.97 (d) together with:
     ☐   Statement under 37 CFR 1.97 (e), and
     ☐   a $180.00 fee set forth in 37 CFR 1.17 (p).
(Filed after final action or notice of allowance, whichever occurs first, but
before payment of the issue fee)

☒   Applicant(s) submit herewith Form PTO 1449- Information Disclosure Citation
together with copies of patents, publications or other information of which applicant(s) are
aware, which applicant(s) believe(s) may be material to the examination of this application and
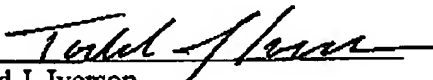for which there may be a duty to disclose in accordance with 37 CFR 1.56.

It is requested that the information disclosed herein be made of record in this
application.

I

Any deficiency or overpayment should be charged or credited to deposit account number 13-1703. A duplicate copy of this sheet is enclosed.

Customer No. 20575

Respectfully submitted,

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> I hereby certify that this correspondence
> is being transmitted to the U.S. Patent and
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INFORMATION DISCLOSURE CITATION
FORM PTO-1449 (Modified)

U.S. PATENT DOCUMENTS

Exam Init	Ref	Document Number	Issue Date	Name	Class	Sub Class
____	____	5,922,495	Jul. 13, 99	Kim		

FOREIGN PATENT DOCUMENTS

Exam Init	Ref	Document Number	Publication Date	Country	Name
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OTHER DOCUMENTS

Exam Init	Ref	Author, Title, Date, Pertinent Pages, Etc.)
____	____	

Examiner: _____

Date Considered: _____

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